



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

March 20, 2026

IGI Report Number

LG772666244

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

ROUND BRILLIANT

Measurements

8.08 - 8.12 X 5.03 MM

GRADING RESULTS

Carat Weight

2.04 CARATS

Color Grade

E

Clarity Grade

VVS 2

Cut Grade

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

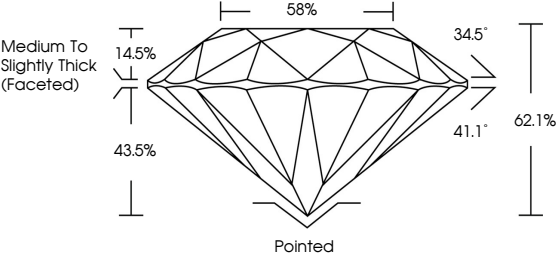
Inscription(s)

 LG772666244

Comments: HEARTS & ARROWS

This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

58%

34.5°

41.1°

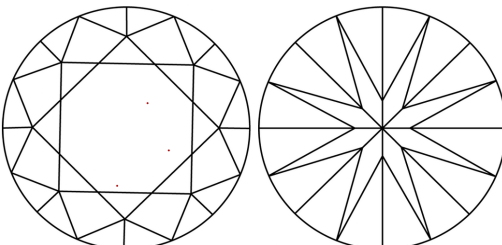
62.1%

43.5%

14.5%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

 Red symbols indicate internal characteristics.

 Green symbols indicate external characteristics.





Sample Image Used

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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IGI Report No LG772666244

ROUND BRILLIANT

8.08 - 8.12 X 5.03 MM

2.04 CARATS

E

VVS 2

IDEAL

88%

Medium To Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

 LG772666244

Cut

Polish

Symmetry

Fluorescence

Inscription(s)

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